

DT15 Rec'd PCT/PTO 23 FEB 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Henry W. White et al.
Application Number: To be assigned
Filing Date: Herewith
Title: A Hybrid Beam Deposition System and Methods for
Fabricating Metal Oxide-ZnO Films, P-Type ZnO Films,
and ZnO-Based II-VI Compound Semiconductor Devices
Group Art Unit: Not yet known
Examiner: Not yet known
Attorney Docket: MOXT-002-US

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Sunshine Limanni

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Commissioner for Patents
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PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified application as follows, prior to the first Office Action, to place the application in condition for allowance.